

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Wunnicke, et al. Docket No.: INF-138  
Serial No.: 10/781,920 Art Unit: 1756  
Filed: February 20, 2004 Examiner: TBD  
For: Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Associate Power of Attorney**


Dear Sir:

I hereby appoint as associate attorneys of record all attorneys at customer number 25962.

Also, please direct all future correspondence to:

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Respectfully submitted,

  
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